

Notice of References Cited

Application/Control No.

10/577,975

Applicant(s)/Patent Under
Reexamination
NIVEN ET AL.

Examiner

VERONICA FAISON GEE

Art Unit

1793

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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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